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AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1792
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q92709

Masahiko ISHIDA, et al.

Appln. No.: 10/564,750

Group Art Unit: 1792

Confirmation No.: 1790

Examiner: Felisa Carla HITESHEW

Filed: January 17, 2006

For: METHOD FOR FIXING METAL PARTICLES AND METHOD FOR
MANUFACTURING SUBSTRATE CONTAINING METAL PARTICLES, METHOD
FOR MANUFACTURING SUBSTRATE CONTAINING CARBON NANOTUBE, AND
METHOD FOR MANUFACTURING SUBSTRATE CONTAINING
SEMICONDUCTOR-CRYSTALLINE ROD, EMPLOYING

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 8, 2009, please amend the above-identified application as follows on the accompanying pages.

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